

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Koichi HASEGAWA et al.

Serial No. 10/575,725

Filed April 13, 2006

SPUTTERING TARGET MATERIAL



Attorney Docket No. 2006_0570A

Confirmation No. 1683

Group Art Unit 1793

Examiner Janell Combs Morillo

Mail Stop: AMENDMENT

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated February 22, 2010, the period for response having been extended for three-months by the attached Petition, please amend the present application as follows: